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MS AF  
REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1752

PATENT  
0649-0804P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Itsuo FUJIWARA et al.

Conf.: 5333

Appl. No.: 09/960,328

Group: 1752

Filed: September 24, 2001

Examiner: Chea

For: PHOTOTHERMOGRAPHIC MATERIAL

LETTER SUBMITTING EXECUTED DECLARATION UNDER 37 CFR 1.132

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**MAY 27 2003**

Sir:

Further to Applicants' Amendment filed April 28, 2003, the attached signed Rule 132 Declaration is respectfully submitted. The Examiner is respectfully requested to take into consideration the attached Rule 132 Declaration in combination with the April 28, 2003 Amendment in determining the patentability of the present invention.

If the Examiner has any questions concerning this application, he is requested to contact Marc S. Weiner (#32,181) at the offices of Birch, Stewart, Kolasch & Birch, LLP.

If necessary, the Commissioner is hereby authorized in this, concurrent, and further replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
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MSW/sh

Enclosure: Executed Rule 132 Declaration